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SERIAL NUMBER 10/802,806	FILING DATE 03/18/2004 RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. 021740A	
APPLICANTS Katsutoshi Izumi, Osaka, JAPAN; Motoi Nakao, Osaka, JAPAN; Yoshiaki Ohbayashi, Nara-shi, JAPAN; Keiji Mine, Osaka, JAPAN; Seisaku Hirai, Osaka, JAPAN; Fumihiko Jobe, Osaka, JAPAN; Tomoyuki Tanaka, Osaka, JAPAN; ** CONTINUING DATA ***** This application is a DIV of 10/351,385 01/27/2003 PAT 6,998,330 ** FOREIGN APPLICATIONS ***** JAPAN 2002-022631 01/31/2002 IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/03/2004					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged		STATE OR COUNTRY JAPAN	SHEETS DRAWING 2	TOTAL CLAIMS 2	INDEPENDENT CLAIMS 2
ADDRESS 23850 ARMSTRONG, KRATZ, QUINTOS, HANSON & BROOKS, LLP 1725 K STREET, NW SUITE 1000 WASHINGTON, DC 20006					
TITLE Manufacturing apparatus for buried insulating layer-type semiconductor silicon carbide substrate					
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